



Docket No. 740756-2100

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE APR -5 2002
TC 2800 MAIL ROOM

In re Patent Application of:)
Hongyong ZHANG et al.) Group Art Unit: 2812
Application Serial No. 09/633,869) Examiner: Victor Simkovic
Filed: August 7, 2000)
For: METHOD FOR LASER-) Date: March 29, 2002
PROCESSING SEMICONDUCTOR
DEVICE

CERTIFICATE OF MAILING

REQUEST FOR RECONSIDERATION

Commissioner for Patents
Washington, D.C. 20231

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 29, 2002

Gwyn J. Cantrell

Sir:

Responsive to the Office Action of November 30, 2001, the statutory period for response having been extended one (1) month to **March 30, 2002**, the following remarks are submitted in connection with the above-identified application.

REMARKS

The Office Action of **November 30, 2001**, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for a One (1) Month Extension of Time* which extends the shortened statutory period for response to **March 30, 2002**. Accordingly, Applicant respectfully submits that this response is timely filed. Claims 1-72 are pending in the present application and, for the reasons set forth below, are believed to be in condition for allowance.

A. 35 U.S.C. §112, 1st Paragraph Rejection

Initially, the Examiner rejects claims 1-72 under 35 U.S.C. §112, 1st paragraph as allegedly containing subject matter which was not described in the specification in such a